

Docket No.: HSI-0001



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Confirmation No.: **1151**

Sang Dae KIM et al.

Group Art Unit: **1763**

Serial No.: **10/621,471**

Examiner: **Richard R. BUEKER**

Filed: **July 18, 2003**

Customer No.: **34610**

For: **SOURCE FOR THERMAL PHYSICAL VAPOR DEPOSITION OF ORGANIC
ELECTROLUMINESCENT LAYERS**

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, Virginia 22314

Sir:

In reply to the Office Action dated July 27, 2005, please amend the above-identified application as follows:

Amendments to the Abstract are reflected in this paper.

Amendments to the Claims are reflected in the listing of claims.

Remarks begin after the listing of the claims.